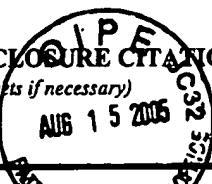


## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

Y0R920030203US1 (16694)

Application Number

10/662,028

Applicant(s)

Stephen W. Bedell, et al.

Filing Date

September 12, 2003

Group Art Unit

366 1742

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
GW		4,104,090	08/01/1978	Pogge, et al.			
GW		5,686,343	11/11/1997	Lee, et al.			

## U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

GW	Mizuno, et al. "High Performance CMOS Operation of Strained-SOI MOSFETs Using Thin Film SiGe-On-Insulator Substrate", 2002 Symposium on VLSI Technology, Digest of Technical Papers, Honolulu, June 11-13, 2002, Symposium on VLSI Technology, New York, NY: IEEE, US, June 11, 2002, pp. 106-107, XP001109839
GW	Patent Abstracts of Japan, Vol. 005, No. 181 (E-083), November 20, 1981, S6-110247.

EXAMINER

DATE CONSIDERED

8/19/05

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**INFORMATION DISCLOSURE CITATION**  
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**Stephen W. Bedell, et al.**

Filing Date  
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**-3661-1742**

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*

*On* Patent Abstracts of Japan, Vol. 005, No. 117 (E-067), May 18, 1981, 56-056648.

EXAMINER *Guy Agypt* DATE CONSIDERED *8/19/05*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.